Docket No.:0756-7263

NIG 0 5 2005 W

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PFIE PATENT application of)	
Shunpei YAMAZAKI, et al.)	
Serial No. 10/799,626)	Group Art Unit: 2813
Filed: March 15, 2004)	Examiner: C. Whitehead, Jr.
For: LASER IRRADIATION APPARATUS, LASER)	
IRRADIATION METHOD, AND METHOD FOR)	
MANUFACTURING A SEMICONDUCTOR DEVICE		

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with The United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P. O. Box 1459, Alexandria VA 22313-1450, on August Y. 2005

REQUEST FOR STATUS

Honorable Commissioner of Patents

P. O. Box 1450

Alexandria VA 22313-1450

Sir:

To date the undersigned attorney of record has received no action in the aboveidentified patent application. Please provide the undersigned with a status report of the application in writing.

Respectfully submitted,

Eric J. Robinson

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PMB 955

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